# PATENT COOPERATION TREATY

# PCT

## **INTERNATIONAL SEARCH REPORT**

(PCT Article 18 and Rules 43 and 44)

Applicant's or agent's file reference	FOR FURTHER	see Form PCT/ISA/220
PCT2109APsw		l as, where applicable, item 5 below.
International application No.	International filing date (day/month/year)	(Earliest) Priority Date (day/month/year)
PCT/EP2004/007386	06/07/2004	07/07/2003
Applicant		
AVALON PHOTONICS AG		
This International Search Report has be according to Article 18. A copy is being	een prepared by this International Searching Aut transmitted to the International Bureau.	hority and is transmitted to the applicant
This International Search Report consis	its of a total of sheets.	
X It is also accompanied to	by a copy of each prior art document cited in this	report.
Basis of the report		
<ul> <li>a. With regard to the language, the language in which it was filed, unlike the language.</li> </ul>	e international search was carried out on the bas inless otherwise indicated under this item.	sis of the international application in the
The internationa this Authority (F	al search was carried out on the basis of a transl Rule 23.1(b)).	ation of the international application furnished to
	eotide and/or amino acid sequence disclosed	in the international application, see Box No. I.
2. Certain claims were fo	ound unsearchable (See Box II).	,
3. Unity of invention is la	cking (see Box III).	
4. With regard to the title,		
	submitted by the applicant.	
	ished by this Authority to read as follows:	
<del></del>	ED TRANSVERSE MODE CONTROL B	Y OPTIMIZING THE INCREASED
	VE TO THE LASER DIMENSIONS	
	•	
5. With regard to the abstract,		
=	submitted by the applicant.	
the text has been establi may, within one month fr	shed, according to Rule 38.2(b), by this Authorit rom the date of mailing of this international searc	y as it appears in Box No. IV. The applicant th report, submit comments to this Authority.
6. With regards to the <b>drawings</b> ,		
a. the figure of the drawings to be	published with the abstract is Figure No. 1a	
X as suggested by		<del></del>
=	nis Authority, because the applicant failed to sugg	gest a figure.
	nls Authority, because this figure better character	_
	pe published with the abstract.	

International application No.

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PCT/EP2004/007386

Box No. IV Text of the abstract (Continuation of item 5 of the first sheet)

The present invention provides a VCSEL device (100) and a method of fabricating the same, wherein two or more characteristic device dimensions (dm, dp) are correlated with each other so as to optimise single mode emission, while at the same time significantly providing an increased oxide aperture (dox) compared to conventional devices. Thus, device lifetime and reliability are enhanced. The present invention may rely on well-established process techniques for VCSEL devices having an oxide aperture (dox), wherein merely one additional mesa etch step is required.

#### INTERNATIONAL SEARCH REPORT

international Application No PCT/EP2004/007386

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 H01S5/183

According to International Patent Classification (IPC) or to both national classification and IPC

#### **B. FIELDS SEARCHED**

Minimum documentation searched (classification system followed by classification symbols) IPC 7 H01S

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC, COMPENDEX, IBM-TDB

l C.	<b>DOCUMENTS</b>	CONSIDERED	TO BE RELEVANT
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Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Х	EP 0 772 266 A (MOTOROLA INC) 7 May 1997 (1997-05-07)	1-14,16, 19,20, 23,25,26
Υ	column 3, lines 16-59; figures 2,3 column 4, line 50 - column 5, line 7	4-8,17, 18,21-29
x	US 5 256 596 A (ACKLEY DONALD E ET AL) 26 October 1993 (1993-10-26)	1,9,12, 13, 15-17, 19,20,23
	column 2, line 28 - column 4, line 12; figures 1,2	19,20,23
	<b>-</b> /	. •

X	Further documents are listed in the continuation of box C.
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γ Patent family members are listed in annex.

- ° Special categories of cited documents:
- "A" document defining the general state of the art which is not considered to be of particular relevance
- "E" earlier document but published on or after the international filing date
- "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
- O document referring to an oral disclosure, use, exhibition or other means
- "P" document published prior to the international filing date but later than the priority date claimed
- "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- \*X\* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.
- "&" document member of the same patent family

Date of the actual completion of the international search

Date of mailing of the international search report

1 October 2004 14/10/2004

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Form PCT/ISA/210 (second sheet) (January 2004)

## INTERNATIONAL SEARCH REPORT

International Application No
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Y SHINADA S ET AL: "Micro-aperture surface emitting laser for near field optical data storage" LASERS AND ELECTRO-OPTICS, 1999. CLEO/PACIFIC RIM '99. THE PACIFIC RIM CONFERENCE ON SEOUL, SOUTH KOREA 30 AUG3 SEPT. 1999, PISCATAWAY, NJ, USA, IEEE, US, 30 August 1999 (1999-08-30), pages 618-619, XP010364559 ISBN: 0-7803-5661-6	7,18,
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Y EP 1 276 188 A (AVALON PHOTONICS AG) 15 January 2003 (2003-01-15) paragraphs '0020!, '0021!, '0033! - '0037!; figure 5	21,22
NISHIYAMA N ET AL: "MULTI-OXIDE LAYER STRUCTURE FOR SINGLE-MODE OPERATION IN VERTICAL-CAVITY SURFACE-EMITTING LASERS" IEEE PHOTONICS TECHNOLOGY LETTERS, IEEE INC. NEW YORK, US, vol. 12, no. 6, June 2000 (2000-06), pages 606-609, XP000951817 ISSN: 1041-1135 the whole document	23,27-29
	-8, 4-29

#### **INTERNATIONAL SEARCH REPORT**

Information on patent family members

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PCT/EP2004/007386

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